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1	L1		8	(" 20020105688" " 20040141023" " 20030030689" " 20030083203") PN	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/10/31 12:04

10/827,457

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Inventor Name Search Result

Your Search was:

Sw 10/827,457

Last Name = MAEKAWA

First Name = SHINJI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
09313081	6261971			METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE BY THERMAL OXIDATION OF AMORPHOUS SEMICONDUCTOR FILM	MAEKAWA, SHINJI
09724403	Not Issued	93	11/27/2000 NO	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE THAT INCLUDES FORMING A MATERIAL WITH A HIGH TENSILE STRESS IN CONTACT WITH A SEMICONDUCTOR FILM TO GETTER IMPURITIES FROM THE SEMICONDUCTOR FILM	MAEKAWA, SHINJI
09783541	Not Issued	164	02/15/2001 ს)	VALVE ASSEMBLY FOR GAS CYLINDER	MAEKAWA, SHINJI
09901619	6518104	150	07/11/2001 VO	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE BY THERMAL OXIDATION OF AN IMPURITY DOPED AMORPHOUS SEMICONDUCTOR FILM	MAEKAWA, SHINJI
10091338	6830994	150		METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	MAEKAWA, SHINJI
10097963	<u>6766829</u>	150	03/15/2002	VALVE ASSEMBLY FOR GAS CYLINDER	MAEKAWA, SHINJI
10112717	6809023	150	1 3	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE	MAEKAWA, SHINJI

			M	HAVING UNIFORM CRYSTAL GRAINS IN A CRYSTALLINE SEMICONDUCTOR FILM	
10141451	Not Issued	71	05/08/2002	Semiconductor device and method of manufacturing the same	MAEKAWA, SHINJI
10157046	6897477	150	05/30/2002	SEMICONDUCTOR DEVICE, MANUFACTURING METHOD THEREOF, AND DISPLAY DEVICE	MAEKAWA, SHINJI
10569595	Not Issued	19	01/01/0001	THIN FILM TRANSISTOR, MANUFACTURING METHOD FOR THIN FILM TRANSISTOR AND MANUFACTURING METHOD FOR DISPLAY DEVICE	MAEKAWA, SHINJI
10573155	Not Issued	20	03/23/2006	Semiconductor device and method for manufacturing the same	MAEKAWA, SHINJI
10573328	Not Issued	19		Manufacturing method of semiconductor device	MAEKAWA, SHINJI
10574616	Not Issued	19	01/01/0001 ANO	Method for forming pattern, thin film transistor, display device and method for manufacturing the same, and television device	MAEKAWA, SHINJI
10575492	Not Issued	20		Method for forming wiring, method for manufacturing thin film transistor and droplet discharging method	MAEKAWA, SHINJI
10577058	Not Issued	19		Liquid crystal display device and manufacturing method thereof	MAEKAWA, SHINJI
10579800	Not Issued	19		Electric appliance, semiconductor device, and method for manufacturing the same	MAEKAWA, SHINJI
10640299	6861338	150	N	THIN FILM TRANSISTOR AND METHOD OF MANUFACTURING THE SAME	MAEKAWA, SHINJI
10685380	Not Issued	41		Method of manufacturing semiconductor device	MAEKAWA, SHINJI
10713219	Not Issued	71	11/17/2003 N	METHOD FOR FABRICATING THIN FILM TRANSISTOR	MAEKAWA, SHINJI
10721251	Not Issued	41	N	semiconductor device	MAEKAWA, SHINJI
10787551	Not	80	02/27/2004 N	Composition of carbon nitride,	MAEKAWA, SHINJI



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	Issued		V	thin film transistor with the composition of carbon nitride, display device with the thin film transistor, and manufacturing method thereof	
10827457	Not Issued	71	04/19/2004	Method for forming pattern and drop discharge apparatus	MAEKAWA, SHINJI
10873285	Not Issued	41	06/23/2004 N	Silicon nitride film, a semiconductor device, a display device and a method for manufacturing a silicon nitride film	MAEKAWA, SHINJI
10879800	Not Issued	71	06/29/2004	Droplet jetting device and method of manufacturing pattern	MAEKAWA, SHINJI
10884945	Not Issued	30	07/07/2004 /	Display device	MAEKAWA, SHINJI
10885074	Not Issued	30	II	Display device and electronic apparatus	MAEKAWA, SHINJI
10885636	Not Issued	93		METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	MAEKAWA, SHINJI
10894434	Not Issued	41	07/20/2004 ?	Manufacturing method of a light emitting device	MAEKAWA, SHINJI
10915428	Not Issued	61		Resist composition and method for manufacturing semiconductor device using the same	MAEKAWA, SHINJI
10930905	6917079	150		THIN FILM TRANSISTOR AND METHOD OF MANUFACTURING THE SAME	MAEKAWA, SHINJI
10954286	Not Issued	41	10/01/2004 /\)	Fabrication method of a semiconductor device	MAEKAWA, SHINJI
10959071	6953717	150		METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE	MAEKAWA, SḤỊNJI
10970299	Not Issued	41	10/21/2004	Methods for forming wiring and manufacturing thin film transistor and droplet discharging method	MAEKAWA, SHINJI
<u>10970712</u> ×	Not Issued	30	10/21/2004	Liquid droplet ejection system and control program of ejection condition of compositions	MAEKAWA, SHINJI
10973986	Not Issued	41	10/27/2004 N	Wiring Substrate and Semiconductor Device	MAEKAWA, SHINJI
10974022	Not Issued	30	10/27/2004 N	Display device	MAEKAWA, SHINJI

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	11025921	Not Issued	30	01/03/2005	Substrate having film pattern and manufacturing method of the same, manufacturing method of semiconductor device, liquid crystal television, and EL television	MAEKAWA, SHINJI
	(11038212)	Not	41	01/21/2005	Display device, manufacturing	MAEKAWA, SHINJI
	11036212	Issued	71	7	method thereof, and television receiver	WALKA WA, SIIII (SI
	11042518	Not Issued	25 .	01/26/2005 ໃ	Display device, method for manufacturing thereof, and television device	MAEKAWA, SHINJI
/	11074671	Not Issued	41	٦,	Semiconductor device, method for manufacturing the same, liquid crystal television and EL television	MAEKAWA, SHINJI
	11085467	7111818	150	03/21/2005	SAFETY VALVE	MAEKAWA, SHINJI
İ	11132288	Not Issued	41		Method for manufacturing semiconductor device	MAEKAWA, SHINJI
k	11134401	Not Issued	71	05/23/2005	Semiconductor device, manufacturing method thereof, and display device	MAEKAWA, SHINJI
	(11137746	Not Issued	30	05/25/2005	Thin film transistor and display device, method for manufacturing the same, and television system	MAEKAWA, SHINJI
	11187988	Not Issued	30	07/25/2005	Display device, manufacturing method thereof, and television set	MAEKAWA, SHINJI
P	11193513	Not Issued	25	08/01/2005	Television, electronic apparatus, and method of fabricating semiconductor device	MAEKAWA, SHINJI
	11195768	Not Issued	30	08/03/2005	Display device provided with semiconductor element and manufacturing method thereof, and electronic device installed with display device provided with semiconductor element	MAEKAWA, SHINJI
	(11205220)	Not Issued	30		Method for manufacturing display device	MAEKAWA, SHINJI
	11222763	Not Issued	30		Method of manufacturing semiconductor device	MAEKAWA, SHINJI
	11292365	Not Issued	41		Semiconductor device and manufacturing method thereof	MAEKAWA, SHINJI
<u>S</u>	earch and Di	splay Mo	ore Rec	cords.		

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Inventor Name Search Result

Your Search was:

Last Name = MAEKAWA

First Name = SHINJI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
11332351	Not Issued	30		Electronic device, semiconductor device and manufacturing method thereof	MAEKAWA, SHINJI
08618421	Not Issued	161	03/08/1996 		MAEKAWAJIRI, SHINJI
08931072	5939542	150	09/15/1997 🔀	DETECTION OF HLA-DR	MAEKAWAJIRI, SHINJI

Inventor Search Completed: No Records to Display.

Saarah Anathan Inventor	Last Name	First Name	
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Inventor Information for 10/827457

Inventor Name	City	State/Country
MAEKAWA, SHINJI	ATSUGI	JAPAN
YAMAZAKI, SHUNPEI	TOKYO	JAPAN
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